



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Hisashi OHTANI et al.)
Serial No. 09/550,598)
Filed: April 17, 2000)
For: SEMICONDUCTOR DEVICE)
AND PROCESS FOR)
PRODUCING THE SAME)

Art Unit: 2814
Examiner: P. Cao

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on July 14, 2003.

Robert M. Stamps

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Sir:

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marsha
8/12/03

In response to the Official Action dated March 12, 2003, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 9 of this paper.

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